



Attorney's Docket No: 013921-000026

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Gehrke et al.	)	
Serial No.: 10/763,588	)	Confirmation No. 7739
Filed: January 24, 2004	)	
	)	
Examiner: M. Guerrero	)	
Art Unit: 2822	)	
	)	
Title: Methods of Fabricating Gallium Nitride	)	
Semiconductor Layers on Substrates	)	
Including Non-Gallium Nitride Posts	)	
	)	

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Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE ACCOMPANYING  
REQUEST FOR CONTINUED EXAMINATION (RCE) UNDER 37 C.F.R. § 1.114**

Sir:

This paper is being filed in response to the Final Office Action mailed October 19, 2005, having a reply due date of January 19, 2006. The Applicants hereby petition the Commissioner for Patents to extend the time for response by three (3) months to April 19, 2006. A Request for Continued Examination and a Declaration pursuant to 37 C.F.R. § 1.131 are included herewith. Appropriate fees for the Request for Continued Examination and a Petition for Extension of Time are also enclosed. If Applicants are mistaken as to the fees, you are authorized to charge any additional fees or credit any overpayment to deposit account 13-4365. Reconsideration of the application is respectfully requested in light of this response.

**Amendments to the Specification** There are no amendments to the specification.

**Amendments to the Claims** There are no amendments to the claims.

**Remarks/Arguments** begin on page 2 of this paper.